

## AMENDMENTS TO THE SPECIFICATION

Please replace the paragraph beginning on page 21, line 28 and ending on page 22, line 6 with the following amended paragraph:

A third embodiment of the present invention is illustrated in  
5 Figs. 3A-3I, which shows a method of fabricating a multi-layer vertical comb-drive structure of the type shown in Figs. 1B-1C. In this method, one set of comb fingers has two layers, while the other has only one layer. Fig. 3A shows a structure 300 containing first conductive layer 302 and second conductive 10 layer 304, and first and second insulating layers 306 and 308, respectively. Also shown is optional substrate layer 310. Structure 300 may be identical to structure substrate 200 of Fig. 2A. Conductive layers 302 and 304 are preferably silicon, while insulating layers 306 and 308 are preferably a silicon 15 oxide formed from thermal oxidation of silicon wafer layers 302 and 304, which are then bonded together.